



Response Under 37 CFR § 1.116 Expedited Procedure - Group 1755

03500.017562.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

	In re Application of:)	<u> </u>
	MAKOTO KUBOTA, ET AL.	:)	Examiner: C. Koslow
	Application No.: 10/665,429	;)	Group Art Unit: 1755
N JE	Filed: September 22, 2003)	
0 0 0 0 0 0 0 0 0 0 0 0 0 0 0 0 0 0 0	For: COMPOSITION FOR FORMING PIEZOELECTRIC FILM, MANUFACTURING METHOD OF PIEZOELECTRIC FILM, PIEZOELECTRIC ELEMENT AND INK JET RECORDING HEAD	; ; ; ; ;	June 29, 2005
	Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450		

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Office Action dated March 29, 2005, please amend

the above-identified application as follows:

United States Postal Service as fit	rst-class mail in an envelope addressed
1450 on	O. Box 1450, Alexandria, VA 22313
June 29,	2005_
(Date of D	eposit)
Damond E. Vadnais, F	Reg. No. 52,310
(Name of Attorney for	or Applicant)
Jan Jahr	June 29, 2005
Signalure	Date of Signature